Editorial Board

Editor-in-Chief
MELVIN KRANZBERG
Georgia Institute of Technology

Associate Editor
AUGUST W. GIEBELHAUS
Georgia Institute of Technology

Exhibits Editor
MERRITT ROE SMITH
Massachusetts Institute of Technology

Hagley Museum

Advisory Editors

BERT S. HALL
ROBIN HIGHTHAM
DAVID A. HOUNSHELL
ALEX KELLER
JOHN A. KOUWENHOVEN
EDWIN T. LAYTON, JR.
SAMUEL LIEBERSTEIN
A. RAHMAN

WAYNE RASMUSSEN
MARGARET W. ROSSITER
DENISE SCHMANDT-BESSERAT
NATHAN SIVIN
DEREK J. DE Solla PRICE
PAUL USELDING
JOAN VANEK
JOHN H. WHITE, JR.

University of Toronto
University of Birmingham
Kansas State University
Harvey Mudd College
University of Leicester
Barnard College
University of Minnesota
St. John's University
Council of Scientific and Industrial Research (India)

U.S. Department of Agriculture
University of California, Berkeley
University of Texas—Austin
University of Pennsylvania
Yale University
University of Illinois
City University of New York
Smithsonian Institution

Technology and Culture (ISSN 0040-165X) is published quarterly, January, April, July, and October, by The University of Chicago Press. Subscriptions: institutions, 1 year $20.00, 2 years $36.00, 3 years $51.00; individuals, 1 year $15.00, 2 years $27.00, 3 years $38.25. Student subscription rate (U.S.A.): 1 year $12.00 (letter from professor must accompany subscription). Single copy rates: institutions $4.50; individuals $3.60. Back issues are available from 1966 (vol. 7). The subscription rate includes membership in the Society for the History of Technology. Checks should be made payable to Technology and Culture, The University of Chicago Press, 5801 Ellis Avenue, Chicago, Illinois 60637; all business correspondence should be sent to that office. All changes of address must include the old as well as the new address. Postmaster: Send address changes to Technology and Culture, 5801 Ellis Avenue, Chicago, Illinois 60637.

Volumes 1 through 6 available from Kraus Reprints, Route 100, Millwood, New York 10546.

Volumes available in microfilm from University Microfilms, 300 North Zeeb Road, Ann Arbor, Michigan 48106; in microfiche from Johnson Associates, P.O. Box 1017, Greenwich, Connecticut 06830, and J. S. Canner & Co., 49–56 Lansdowne Street, Boston, Massachusetts 02215.

Manuscripts, books for review, and other editorial correspondence should be sent to DR. MELVIN KRANZBERG, Editor, Society for the History of Technology, Georgia Institute of Technology, Atlanta, Georgia 30332.


© 1979 by the Society for the History of Technology. All rights reserved. PRINTED IN U.S.A.